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## \*BIBDATASHEET\*

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**CONFIRMATION NO. 7951** 

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** CONTINUING DATA **********************************										
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Foreign Priority claim 35 USC 119 (a-d) cor met Verified and Acknowledged	nditions <u>C</u>	KI, C. Warla	Allowance nitials	STATE OR  COUNTRY  KOREA,  REPUBLIC  OF		HEETS RAWING 3	TO <sup>-</sup> CLA 3	IMS	INDEPENDENT CLAIMS 4	
ADDRESS Frank Chau, Esq. F. CHAU & ASSOCIATES, LLC 1900 Hempstead Turnpike East Meadow , NY 11554										
TITLE Method of forming an underlayer of a bi-layer resist film and method of fabricating a semiconductor device using the same										
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FILING FEE	FEES:	Authority has been giv	en in Paper			☐ 1.16 Fees (Filing) ☐ 1.17 Fees (Processing Ext. of				
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